

Subst. Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

SAM-151

Application Number

Applicant

Won-Suk Yang t al.

Filing Date

Her with

Group Art Unit

2814

U. S. Patent Documents

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>[initials]</i>	AA	4,966,870	10/30/90	Barber et al.	437	228	8/8/89
<i>[initials]</i>	AB	5,466,636	11/14/95	Cronin et al.	437	187	9/17/92
<i>[initials]</i>	AC	5,612,254	3/18/97	Mu et al.	437	195	6/29/92
<i>[initials]</i>	AD	5,808,335	9/15/98	Sung	257	306	7/14/97
<i>[initials]</i>	AE	5,891,799	4/6/99	Tsui	438	624	8/18/97
<i>[initials]</i>	AF	5,895,239	4/20/99	Jeng et al.	438	239	9/14/98
<i>[initials]</i>	AG	5,918,120	6/29/99	Huang	438	239	7/24/98
<i>[initials]</i>	AH	6,083,824	7/4/00	Tsai et al.	438	629	7/13/98
<i>[initials]</i>	AI	6,022,776	2/8/00	Lien et al.	438	253	4/7/99
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>[initials]</i>	AR	"Impact of passivation film deposition and post-annealing on the reliability of flash memories," Shuto et al., 1997 IEEE International Reliability Physics Symposium Proceedings (35 th Annual), pgs. 17-24.
	AS	
	AT	

EXAMINER

DATE CONSIDERED

6/26/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.

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